

Application/Control No.	Applicant(s)/Patent under Reexamination
10/725,047	LU ET AL.
Examiner	Art Unit
Lisa M. Caputo	2876

	SEARCHED		
Class	Subclass	Date	Examiner
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INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
consult with D. Lee, primary 235	3/9/2005	LMC